



**ELECTRONIC COPY**

LG742522719  
Report verification at igi.org



October 31, 2025

IGI Report Number **LG742522719**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **16.89 X 11.67 X 7.75 MM**

**GRADING RESULTS**

Carat Weight **15.41 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

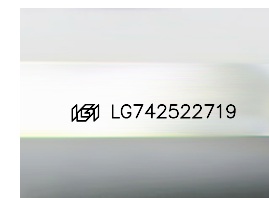
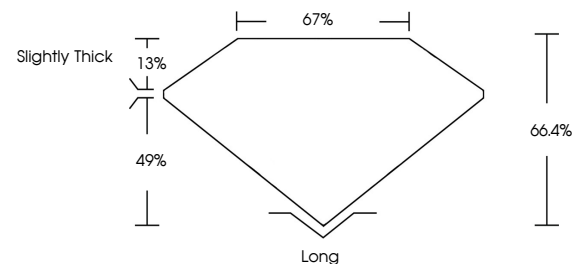
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG742522719**

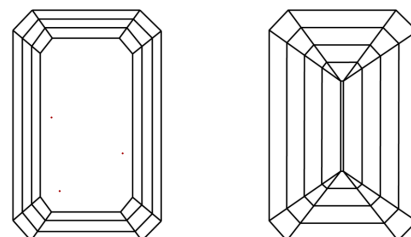
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

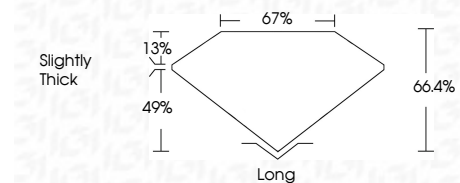
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Polish **EXCELLENT**

Symmetry **EXCELLENT**

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**IGI**



October 31, 2025  
IGI Report No LG742522719  
**EMERALD CUT**

**16.89 X 11.67 X 7.75 MM**

Carat Weight **15.41 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Depth **66.4%**  
Table **67%**  
Girdle **Slightly Thick**

Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG742522719**

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